## Notic of References Cited Application/Gontrol No. 09/282,772 Applicant(s)/Patent Under Reexamination TANUMA ET AL. Examiner Mike Qi Applicant(s)/Patent Under Reexamination TANUMA ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name Classifi		fication
	Α	US-6,201,588-	03-2001	Walton et al	349	123
	В	US-5,907,380-	05-1999	Lein	349	144
	С	US-6,177,973- /	01-2001	Lee et al	349	123
	D	US-5,374,374-	12-1994	Weber et al	252	299
	Ε	US-6,181,402-	01-2001	Shim et al	349	130
	F	US-6,144,434-	11-2000	Kim et al	349	130
	G	US-6,222,599-	04-2001	Yoshida et al	349	106
	Н	US-6,097,465-	08-2000	Hiroki et al	349	141
	1	US-5,495,355-	02-1996	Konuma	359	78
	J	US-6,180,026-	06-2001	Rieger et al	252	299.63
	к	US				
	L	US				
	М	US				

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification	
	N	-					
	0						
	Р						
	Q						
	R						
	s						
	Т						

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	υ	
	v	
	w	Attorney phone # 312-360-0080
	х	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.